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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Haerle

Art Unit : 2824

Serial No. : 10/625,118

Examiner : Beth E. Owens

Filed : July 22, 2003

Title : METHOD OF PRODUCTION OF SEMICONDUCTOR COMPONENTS

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF FEBRUARY 24, 2004

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

May 24, 2004

Date of Deposit

Signature

Nikia M. Mc Nillion

Typed or Printed Name of Person Signing Certificate